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Front Matter: Volume 11801

, "Front Matter: Volume 11801," Proc. SPIE 11801, UV and Higher Energy Photonics: From Materials to Applications 2021, 1180101 (23 August 2021); doi: 10.1117/12.2606438

SPIE.

Event: SPIE Nanoscience + Engineering, 2021, San Diego, California, United States

PROCEEDINGS OF SPIE

UV and Higher Energy Photonics: From Materials to Applications 2021

**Yong-Hoon Cho
Gilles Lrondel
Atsushi Taguchi**
Editors

**1–5 August 2021
San Diego, California, United States**

Sponsored and Published by
SPIE

Volume 11801

Proceedings of SPIE 0277-786X, V. 11801

SPIE is an international society advancing an interdisciplinary approach to the science and application of light.

UV and Higher Energy Photonics: From Materials to Applications 2021, edited by
Yong-Hoon Cho, Gilles Lrondel, Atsushi Taguchi, Proc. of SPIE Vol. 11801,
1180101 · 2021 SPIE · CCC code: 0277-786X/21/\$21 · doi: 10.1117/12.2606438

Proc. of SPIE Vol. 11801 1180101-1

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Author(s), "Title of Paper," in *UV and Higher Energy Photonics: From Materials to Applications 2021*, edited by Yong-Hoon Cho, Gilles Lérondel, Atsushi Taguchi, Proc. of SPIE 11801, Seven-digit Article CID Number (DD/MM/YYYY); (DOI URL).

ISSN: 0277-786X

ISSN: 1996-756X (electronic)

ISBN: 9781510644403

ISBN: 9781510644410 (electronic)

Published by

SPIE

P.O. Box 10, Bellingham, Washington 98227-0010 USA

Telephone +1 360 676 3290 (Pacific Time)

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